

Notice of References Cited	Application/Control No. 10/651,328		Applicant(s)/Patent Under Reexamination KANG ET AL.	
	Examiner Philip Wang		Art Unit 2191	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
*	C	US-5,862,316 A	01-1999	Hagersten et al.	714/15
*	D	US-6,061,518 A	05-2000	Hoffman, Richard Dale	717/124
*	E	US-2003/0131282 A1	07-2003	Lowen et al.	714/20
*	F	US-6,611,844 B1	08-2003	Saulpaugh et al.	707/103R
*	G	US-2004/0111696 A1	06-2004	Soroker et al.	717/101
*	H	US-2004/0153878 A1	08-2004	Bromwich et al.	714/048
*	I	US-6,901,539 B2	05-2005	Achtelstetter, Dieter	714/44
*	J	US-7,017,077 B2	03-2006	Lowen et al.	714/20
*	K	US-7,096,339 B2	08-2006	Nelson, Kenneth Carlin	711/170
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	"The Error Handling Interface(H5E)", http://hdf.ncsa.uiuc.edu/HDF5/doc/Errors.html , printed on 11/30/2006
	V	"Debugging HDF5 Applications", http://hdf.ncsa.uiuc.edu/HDF5/doc/Debugging.html , printed on 11/30/2006
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.